



1449 REPRODUCE PATENTS & TRADEMARKS INFORMATION DISCLOSURE CITATION IN AN APPLICATION 5/17/2004 (Use several sheets if necessary)	ATTORNEY DOCKET NO. 301500.3000-106	APPLICATION NO. 10/662,892
	APPLICANT Oleg P. Kishkovich <i>et al.</i>	
	FILING DATE September 15, 2003	GROUP ART UNIT 2812

U.S. PATENT DOCUMENTS

EXAM- -NER INI- TIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE
AS	AA	3,834,122	Sep 10 1974	Allison et al.	55	33	
	AB	4,170,901	Oct 16 1979	Conkle et al.	73	421.5	
	AC	4,429,736	Feb 07 1984	Turner	165	61	
	AD	4,645,516	Feb 24 1987	Doshi	55	16	
	AE	5,122,355	Jun 16 1992	Prasad et al.	423	351	
	AF	5,574,230	Nov 12 1996	Baugh	73	863.23	
	AG	5,773,713	Jun 30 1998	Barber et al.	73	61.41	
	AH	4,998,433	Mar 12 1991	Stumpf et al.	73	25.01	
	AI	5,856,198	Jan 5 1999	Joffe et al.	436	100	
	AJ	5,983,704	Nov 16 1999	Park et al.	73	28.01	
	AK	6,096,267	Aug 1 2000	Kishkovich et al.	422	52	
	AA2	6,287,023	Sep 11 2001	Yaegashi et al.	396	565	
	AB2	6,290,779	Sep 18 2001	Saleh et al.	134	2	
V	AC2	5,274,434	Dec 28 1993	Morioka et al.	356	237	

FOREIGN PATENT DOCUMENTS

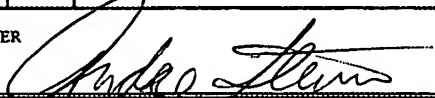
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO
AG	AL	DE 198 47 697	20 Apr 2000	Denmark (English Abstract)			
	AM	EP 0 692 297	17 Jan 1996	EPO			
	AN	EP 1 166 845	27 Jun 2001	EPO			
	AO	JP 11-57346	02 Mar 1999	Japan (English Abstract)			
	AP	JP 11-64316	05 Mar 1999	Japan (English Abstract)			
	AQ	JP 11-20034	26 Jan 1999	Japan (English Abstract)			
	AL2	DE 198 41 814	16 MAR 2000	Denmark			X
	AM2	EP 0 298 000	04 Jan 1989	EPO			
V	AN2	EP 1 190 945	27 Mar 2002	EPO			

EXAMINER

DATE CONSIDERED

07-08-05

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EXAM- INER INI- TIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE
AS	AD2	4,474,051	Oct 2 1984	Fukuda et al.	73	19	
	AE2	5,054,046	Oct 1 1991	Shoulders	378	119	
	AF2	5,153,901	Oct 6 1992	Shoulders	378	119	
	AG2	5,168,068	Dec 1 1992	Yanagisawa et al.	436	134	
	AH2	6,168,948	Jan 2 2001	Anderson et al.	435	287.2	
	AI2	5,481,110	Jan 2 1996	Krishnaswamy et al.	250	288	
	AJ2	5,725,634	Mar 10 1998	Takasuga et al.	95	45	
	AK2	5,841,022	Nov 24 1998	Hase	73	23.22	
	AA3	5,898,114	Apr 27 1999	Basch et al.	73	863.23	
	AB3	5,935,302	Aug 10 1999	Ju et al.	96	4	
	AC3	6,009,739	Jan 4 2000	Fujiwara et al.	73	1.02	
	AD3	6,119,532	Sep 19 2000	Park et al.	73	864.34	
	AE3	6,139,801	Oct 31 2000	Kawachi et al.	422	88	
	AF3	6,239,038	May 29 2001	Wen	438	745	
	AG3	6,295,864	Oct 2 2001	You et al.	73	53.01	
	AH3	6,310,356	Oct 30 2001	Yuhara et al.	250	574	
	AI3	6,467,333	Oct 22 2002	Lewis et al.	73	31.05	
	AJ3	6,470,760	Oct 29 2002	Shinozaki et al.	73	863.33	
	AK3	6,497,136	Dec 24 2002	Satou	73	23.22	
	AA4	6,620,630	Sep 16 2003	Kishkovish et al.	438	7	
✓	AB4	2002/0121148 A1	Sep 5 2002	Shinozaki et al.	73	863.33	Jun 29 1999
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		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO
	AO2	2 320 088	10 Jun 1998	UK patent application			
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
98	AR	Ogawa & Company, company website, www.ogawausa.com, About Ogawa & Company, July 24, 2003.	
98	AS	Ogawa & Company, company website, www.ogawausa.com, Passive Sampler, July 24, 2003.	
98	AT	Dallas, et al., "Characterization and Control of Organic Airborne Contamination in Lithographic Processing", Paper presented at SPIE Microlithography 2002.	
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		07-08-05	